

THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Applicant:

Michael L. McSwiney et al.

Art Unit: 1792

Serial No.:

10/764,193

David P. Turocy

Filed:

January 23, 2004

Atty Docket: ITL.1056US

Examiner:

P17793

For:

Forming a Silicon

Nitride Film

\$ \$ \$ \$ \$ \$ \$ \$ \$ \$ \$ \$ \$ \$ \$

Assignee:

Intel Corporation

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

REPLY TO OFFICE ACTION

Sir:

In response to the office action mailed March 17, 2008, please amend the abovereferenced patent application as follows:

> Date of Deposit: June 5, 2008
> I hereby certify under 37 CFR 1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated above and is addressed to the Commissioner for Patents, P.O. Box 1450,